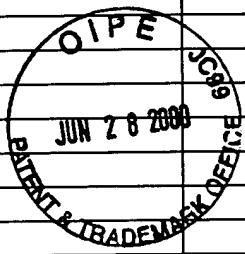


Form PTO-1449 (Rev. 2-32)		U.S. Department of Commerce Patent & Trademark Office	Atty. Docket No. Q56557	Serial No. 09/539,412		
INFORMATION DISCLOSURE STATEMENT (Use several sheets if necessary)		Applicant: Masaharu OGAWA, et al.				
		Filing Date: March 30, 2000	Group: Not yet assigned	2878		
U.S. PATENT DOCUMENTS						
Examiner Initial		Document Number	Date	Name	Class	Sub-Class
SK		4,535,468	8/13/85	Kempter	378/31	
						
FOREIGN PATENT DOCUMENTS						
		Document	Date	Country	Class	Sub-class
SK		10-232824 J	2/9/98	JP	G06F	12/06
SK		10-271374 ✓	9/10/98	JP	H04N	5/225
OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, Etc.)						
<p><u>"Technique of Processing for Ultra Fine Structure"</u>, Tokuyama Takashi, Ohmsha, pp. 1-11 and pp. 288-301</p>						
EXAMINER: <u>SL Lee</u>		DATE CONSIDERED: <u>4/19/02</u>				
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